



ELECTRONIC COPY

LG811691014
Report verification at igi.org



June 22, 2026

IGI Report Number **LG811691014**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **11.84 X 8.23 X 5.05 MM**

GRADING RESULTS

Carat Weight **3.07 CARATS**

Color Grade **G**

Clarity Grade **VVS 2**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

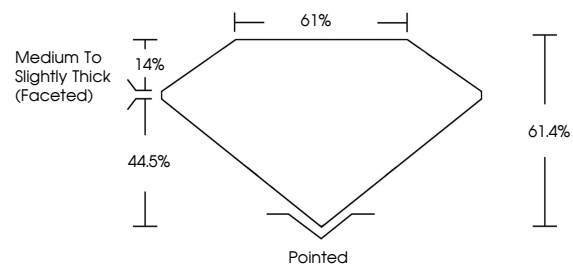
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG811691014**

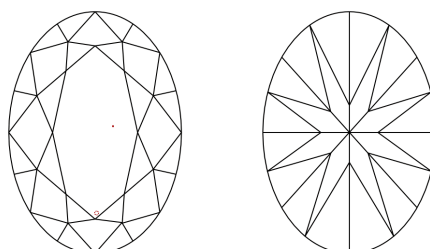
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

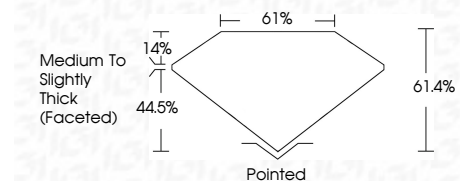
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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Fluorescence **NONE**

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IGI



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IGI Report No LG811691014
OVAL BRILLIANT

3.07 CARATS
G

11.84 X 8.23 X 5.05 MM

Carat Weight
Color Grade
Clarity Grade
Table
Depth
Girdle

VVS 2
G
VVS 2
61.4%
61%

Medium to Slightly Thick (Faceted)

Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG811691014

Culet
Polish
Symmetry
Fluorescence
Inscription(s)

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